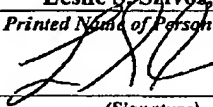


|  |                                       |                                |                                |  |
|--|---------------------------------------|--------------------------------|--------------------------------|--|
| <b>CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)</b>   |                                       |                                | <b>Docket No.</b>              |  |
| Applicant(s): <b>Douglas D. Coolbaugh et al.</b>   |                                       |                                | <b>BUR920040067US1 (17542)</b> |  |
| <b>Application No.</b><br>10/711,130   | <b>Filing Date</b><br>August 26, 2004 | <b>Examiner</b><br>Dung Anh Le | <b>Group Art Unit</b><br>2818  |  |
| <b>Invention: METHOD OF ADJUSTING RESISTORS POST SILICIDE PROCESS</b>  |                                       |                                |                                |  |
| <b>RECEIVED<br/>CENTRAL FAX CENTER<br/>NOV 11 2005</b>   |                                       |                                |                                |  |
| <p>I hereby certify that this <u>RESPONSE UNDER 37 C.F.R. § 1.111</u><br/>(Identify type of correspondence)</p> <p>is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>571-273-8300</u>)</p> <p>on <u>November 11, 2005</u><br/>(Date)</p> <p style="text-align: right;"><u>Leslie S. Szivos, Ph.D.</u><br/>(Typed or Printed Name of Person Signing Certificate)</p> <p style="text-align: right;"><br/>(Signature)</p> |                                       |                                |                                |  |
| <b>Note: Each paper must have its own certificate of mailing.</b>  |                                       |                                |                                |  |

P18/REV02

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Douglas D. Coolbaugh et al.

Examiner: Dung Anh Le

Serial No: 10/711,130

Art Unit: 2818

Filed: August 26, 2004

Docket: BUR920040067US1 (17542)

For: METHOD OF ADJUSTING RESISTORS  
POST SILICIDE PROCESS

Dated: November 11, 2005

Confirmation No: 5129

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE UNDER 37 C.F.R. § 1.111**

Sir:

In response to the Office Action dated August 11, 2005, applicants submit the following remarks for entry of record in the above-identified patent application. Applicants also submit herewith a Terminal Disclaimer.

**CERTIFICATION OF FACSIMILE TRANSMISSION**

I hereby certify that this document is being filed in the United States Patent and Trademark Office on the date shown below via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450 at United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

Dated: November 11, 2005

  
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Leslie S. Szivos, Ph.D.

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